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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Kazuhiko ITAYA, et al.

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HEREWITH

INTERNATIONAL APPLICATION NO.: PCT/JP06/307155

INTERNATIONAL FILING DATE: March 29, 2006

FOR: THIN FILM PIEZOELECTRIC RESONATOR AND METHOD OF MANUFACTURING

THE SAME

## REQUEST FOR PRIORITY UNDER 35 U.S.C. 119 AND THE INTERNATIONAL CONVENTION

Commissioner for Patents Alexandria, Virginia 22313

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the applicant claims as priority:

**COUNTRY** 

**APPLICATION NO** 

DAY/MONTH/YEAR

Japan 2005-229815

08 August 2005

Certified copies of the corresponding Convention application(s) were submitted to the International Bureau in PCT Application No. PCT/JP06/307155.

Respectfully submitted, OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

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